

POSTER SESSION PROGRAM

P-1 Floating Gate GaN HEMT for Normally-Off Operation

Hiroki Iwata, Yudai Watariguchi, Hayato Kosaka, Tomoyuki Suwa,
Yoshiteru Amemiya and Akinobu Teramoto

P-2 New Isolation Method for MTJ Fabrication Using SiN-Sidewall

Hiroki Nakanishi, Junichi Tsuchimoto, Hiroyuki Hosoya, Yoshiteru Amemiya,
Chihiro Watanabe, and Akinobu Teramoto

P-3 ALD Research to Realize Area Selective Process

Kazuma Uesugi, Yoshiteru Amemiya, and Akinobu Teramoto

P-4 Statistical Evaluation of 1/f Noise in MOSFETs

Tatsuki Ueta and Akinobu Teramoto

P-5 Research on Self-Aligned Lithography for Miniaturization of Integrated Circuits

Kyosuke Yoshioka, Yoshiteru Amemiya, Kazuma Uesugi, and Akinobu Teramoto

P-6 Reduction of Contact Resistance in GaN/Metal

Yudai Watariguchi Yoshiteru Amemiya, Hiroki Iwata, Tomoyuki Suwa, and Akinobu Teramoto

P-7 High-Temperature Operation of 4H-SiC MOSFETs Based Differential Amplifier for Harsh Environment Applications

Vuong Van Cuong, Tatsuya Meguro, Seiji Ishikawa, Tomonori Maeda,
Hiroshi Sezaki, and Shin-Ichiro Kuroki

P-8 4H-SiC CMOS Well Formation by using Epitaxial Growth Processes

Toya Kai, Kazutoshi Kojima, Takuma Shima, Takeshi Ohshima,
Yasunori Tanaka, and Shin-Ichiro Kuroki

P-9 Si-SOI/4H-SiC Wafer Direct Bonding with SiO₂ insertion

Kazuya Kawamura, Tatsuya Meguro, Masayuki Tsutsumi, Takeshi Ohshima,
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- P-10 Output Characteristics and Fabrication Process of SOI-Si/4H-SiC Hybrid Pixel Device for Radiation Hardened CMOS Image Sensors**
Tatsuya Meguro, Masayuki Tsutsumi, Akinori Takeyama, Takeshi Ohshima,
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- P-11 High Temperature Operation and Reliability of 4H-SiC CMOS Inverters**
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- P-12 High-Selective Deep RIE of 4H-SiC with SiO₂ Hard Mask in Cl₂/HBr/O₂ Plasma Chemistry**
Riku Takeuchi, Tadashi Sato, and Shin-Ichiro Kuroki
- P-13 Characteristics of 4H-SiC Photodiode and Single-pixel Device for Radiation Hardened UV Image Sensor**
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- P-14 Research on Real-Time Temperature Measurement for SiC Wafer during Ultra-Rapid Thermal Annealing Based on Optical-Interference Contactless Thermometry (OICT)**
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- P-15 Electroluminescence from Alq₃-Containing Electron Beam Resist for Light Emitting Organic Nanometer-Scale Devices**
Anri Nakajima, Hiroki Sakurai, and Shuhei Abe
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- P-17 A Development of Denoising Autoencoder on Anomaly Detection via Cutmix for Computer-Aided Diagnosis in Colorectal NBI Endoscopy**
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